Notice of References Cited Application/Control No. 10/573,671 Examiner Ellen Kim Applicant(s)/Patent Under Reexamination HILL ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,991,479 A	11-1999	Kleinerman, Marcos Y.	385/31
*	В	US-2002/0194932 A1	12-2002	Gysling et al.	73/861.42
*	С	US-6,575,033 B1	06-2003	Knudsen et al.	73/514.26
*	D	US-2004/0080432 A1	04-2004	Hill et al.	340/942
*	Е	US-7,036,601 B2	05-2006	Berg et al.	166/385
*	F	US-2006/0157239 A1	07-2006	Ramos et al.	166/254.2
*	G	US-7,187,620 B2	03-2007	Nutt et al.	367/25
	Н	US-		F 27 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7	
	ı	US-	i i		
	J	US-			
	K	US-	1		
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s					
	I				100	

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Cranch et al, "Large-Scale Multiplexing of Interferometric Fiber-Optic Sensors Using TDM and DWDM", Journal of Lightwave Technology, Vol. 19, No. 5, May 2001, pp 687-699
	V	
	W	
	x	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.